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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Yukio TAKIGAWA et al.**

Group Art Unit: **2818**

Application Number: **10/816,958**

Examiner: **Dung Anh Le**

Filed: **April 5, 2004**

Confirmation Number: **2429**

For: **METHOD FOR FABRICATING SEMICONDUCTOR DEVICE**

Attorney Docket Number: **042323**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. §1.116
EXPEDITED PROCESSING REQUESTED

MAIL STOP AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

July 17, 2006

Sir:

In response to the Office Action dated April 17, 2006, Applicants amend the claims as follows and submit the following remarks.

Remarks/Arguments begin on page 2 of this paper.